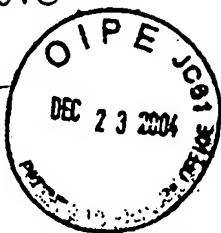


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AF/ 2814  
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**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/072,658  
Filing Date: February 7, 2002  
Applicant: Tomoyuki Furuhashi et al.  
Group Art Unit: 2814  
Examiner: Marcos D. Pizarro-Crespo  
Title: SEMICONDUCTOR DEVICE AND METHOD FOR  
MANUFACTURING THE SAME  
Attorney Docket: 9319S-000328

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Director of The United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AFTER FINAL**

Sir:

In response to the Office Action mailed September 30, 2004, please amend the application as follows and consider the remarks set forth below.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 8 of this paper.